

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/724,791	12/01/2003		Michael B. Korzenski	020732-100.686	1912
24239	7590	10/27/2006		EXAMINER	
MOORE & P.O. BOX 1		LLEN PLLC		UMEZ ERONIN	I, LYNETTE T
		k, NC 27709	ART UNIT	PAPER NUMBER	
				1765	
				DATE MAILED: 10/27/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

Advisory Action Before the Filing of an Appeal Brief

Application No.	Applicant(s)			
10/724,791	KORZENSKI ET AL.			
Examiner	Art Unit			
Lynette T. Umez-Eronini	1765			

	Lynette 1. Umez-Eronir	ור	1/65	
The MAILING DATE of this communication appear	ars on the cover sheet	with the	correspondence add	ress
THE REPLY FILED 09 October 2006 FAILS TO PLACE THIS A	PPLICATION IN COND	ITION FOR	R ALLOWANCE.	
1. The reply was filed after a final rejection, but prior to or on this application, applicant must timely file one of the follow places the application in condition for allowance; (2) a Not a Request for Continued Examination (RCE) in compliance time periods:	ving replies: (1) an amer lice of Appeal (with appe e with 37 CFR 1.114. Th	ndment, af eal fee) in	fidavit, or other evider compliance with 37 C	rce, which FR 41.31; or (3)
 a) The period for reply expiresmonths from the mailing b) The period for reply expires on: (1) the mailing date of this A no event, however, will the statutory period for reply expire la 	dvisory Action, or (2) the da			
Examiner Note: If box 1 is checked, check either box (a) or (TWO MONTHS OF THE FINAL REJECTION. See MPEP 70	b). ONLY CHECK BOX (b) 16.07(f).	WHEN TH	E FIRST REPLY WAS F	ILED WITHIN
Extensions of time may be obtained under 37 CFR 1.136(a). The date have been filed is the date for purposes of determining the period of ext under 37 CFR 1.17(a) is calculated from: (1) the expiration date of the s set forth in (b) above, if checked. Any reply received by the Office later may reduce any earned patent term adjustment. See 37 CFR 1.704(b). NOTICE OF APPEAL	ension and the correspond hortened statutory period for than three months after the	ing amount or reply orig	of the fee. The appropri	ate extension fee ce action; or (2) as
 The Notice of Appeal was filed on A brief in comp filing the Notice of Appeal (37 CFR 41.37(a)), or any exter a Notice of Appeal has been filed, any reply must be filed AMENDMENTS 	nsion thereof (37 CFR 4	1.37(e)), to	avoid dismissal of th	ns of the date of e appeal. Since
3. The proposed amendment(s) filed after a final rejection, to (a) They raise new issues that would require further core	nsideration and/or searc	ing a brief h (see NO	, will <u>not</u> be entered be TE below);	ecause
 (b) They raise the issue of new matter (see NOTE below (c) They are not deemed to place the application in beth appeal; and/or 	er form for appeal by m	-		the issues for
(d) They present additional claims without canceling a continuation Sheet. (See 37 CFR 1.12)		f finally rej	ected claims.	
4. The amendments are not in compliance with 37 CFR 1.12	• • •	of Non-Co	mnliant Amendment	(PTOL-324)
5. Applicant's reply has overcome the following rejection(s):		0	mphane / anonamone ((1 102 024).
6. Newly proposed or amended claim(s) would be all non-allowable claim(s).	owable if submitted in a	•	•	•
7. For purposes of appeal, the proposed amendment(s): a) how the new or amended claims would be rejected is proved the status of the claim(s) is (or will be) as follows: Claim(s) allowed: <u>none</u> . Claim(s) objected to: <u>none</u> . Claim(s) rejected: <u>1-8,12,14,39 and 40</u> . Claim(s) withdrawn from consideration: <u>17,20-25,27,29-31</u>	ided below or appended	orb) □ wi d.	II be entered and an e	explanation of
AFFIDAVIT OR OTHER EVIDENCE	, <u>00 0.10 00 00</u> .			
 The affidavit or other evidence filed after a final action, but because applicant failed to provide a showing of good and was not earlier presented. See 37 CFR 1.116(e). 	before or on the date o sufficient reasons why	f filing a N the affidav	otice of Appeal will <u>no</u> vit or other evidence is	t be entered necessary and
9. The affidavit or other evidence filed after the date of filing a entered because the affidavit or other evidence failed to o showing a good and sufficient reasons why it is necessary	vercome all rejections u	nder appe	al and/or appellant fai	ls to provide a
 The affidavit or other evidence is entered. An explanation REQUEST FOR RECONSIDERATION/OTHER 	of the status of the clai	ms after e	ntry is below or attach	ed.
11. The request for reconsideration has been considered but	does NOT place the ap	plication in	n condition for allowar	nce because:
12. Note the attached Information Disclosure Statement(s). (13. Other:	PTO/SB/08) Paper No(s	Ta	Triffi Gorgos	
	_	MSA See comp	ry Patent Examiner	
	5	VISU Technol	onv Center 1700	

U.S. Patent and Trademark Office PTOL-303 (Rev. 08-06)

Continuation of 3. NOTE:

- In (Currently Amended) Claim 1, "A sacrifical silicon-containing layer etching composition, comprising --a-- supericritical --fluid (SCF)-- . . and at least one --non-ionic-- surfactant . . .";
- In (Withdrawn) Claim 17, "A method of removing silicon-containing substances . . . with a SCF-based composition, comprising --SCF-- . . . and at least one --non-ionic-- surfactant . . . ";
- In (Currently Amended) Claim 39, "A sacrificial silicon-containing layer etching composition consisting essentially of --a-- supercritical -- fluid-- . . . or . . .fluorinated C1-C4 alkyl groups";
 - In (Currently Amended) Claim 40, "A sacrificial silicon-containing layer etching composition consisting of --a-- supercritical --fluid-- . . . "; In (New) Claim 41, " The composition of claim 1, wherein the SCF is selected from the group consisting of carbon dioxide, oxygen,
- argon, kryptom, xenon, and ammonia"; In (New) Claim 42 "--The composition of claim 1, wherein the SCF is carbon dioxide---"; and
- In (New) Claim 43, "--A method of producing Micro Electro Mechanical Systems (MEMS) devices. . . from the substrate--" raise new issues that require further consideration.